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APPLICATION NUMBER	FILING OR 371(c) DATE	FIRST NAMED APPLICANT	ATTY. DOCKET NO./TITLE
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**CONFIRMATION NO. 3409**

25944  
OLIFF & BERRIDGE, PLC  
P.O. BOX 19928  
ALEXANDRIA, VA 22320

**Title:** Silicon single crystal, a silicon wafer, an apparatus for producing the same, and a method for producing the same

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